

*A. Smith et al.  
Preliminary Amendment  
Divisional Application*

**IN THE SPECIFICATION**

Please replace the paragraph at page 1, line 4, to line 14, with the following:

*Cross Reference To Related Applications*

The present application is a divisional application of U.S. Application No. 10/020,569 filed December 7, 2001, entitled "Reference Wafer and Process for Manufacturing Same", by Adlai Smith, Bruce McArthur, and Robert Hunter, which claims priority to U.S. Provisional Application Serial No. 60/254,271 filed December 8, 2000, and U.S. Patent Application Serial No. 09/835,201 filed April 13, 2001, both applications entitled "Method and Apparatus for Self-Referenced Projection Lens Distortion Mapping", by Adlai Smith, Bruce McArthur, and Robert Hunter; U.S. Provisional Application Serial No. 60/254,413 filed December 8, 2000 and U.S. Patent Application Serial No. 09/891,699 filed June 26, 2001, both applications entitled "Method and Apparatus for Self-Referenced Wafer Stage Positional Error", to Adlai Smith, Bruce McArthur, and Robert Hunter; and U.S. Provisional Application Serial No. 60/254,315 filed December 8, 2000 entitled "Reference Wafer and Process for Manufacturing Same", to Adlai Smith, Bruce McArthur, and Robert Hunter, all of which are incorporated by reference in their entirety herein.